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CONFIRMATION NO. 4666

<b>SERIAL NUMBER</b> 10/501,522	<b>FILING OR 371(c) DATE</b> 07/16/2004 <b>RULE</b>	<b>CLASS</b> 438	<b>GROUP ART UNIT</b> 2812	<b>ATTORNEY DOCKET NO.</b> ABE-025	
<b>APPLICANTS</b> Naoshi Adachi, Tokyo, JAPAN; Masahiko Nakamae, Tokyo, JAPAN;  <b>** CONTINUING DATA *****SDF</b> This application is a 371 of PCT/JP03/13514 10/22/2003 <b>** FOREIGN APPLICATIONS *****SDF</b> JAPAN 2002-307478 10/22/2002					
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Verified and Acknowledged <i>Harold Chan</i> SDF Examiner's Signature Initials		<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWING</b> 8	<b>TOTAL CLAIMS</b> 11	<b>INDEPENDENT CLAIMS</b> 2
<b>ADDRESS</b> Kubovcik & Kubovcik The Farragut Building Suite 710 900 17th Street NW Washington, DC20006					
<b>TITLE</b> Pasted soi substrate, process for producing the same and semiconductor device					
<b>FILING FEE RECEIVED</b> 920	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		